

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	Group Art Unit: 2624
Kazuya FUKUHARA	)	
	)	Examiner: Mia M. THOMAS
Application No.: 10/776,591	)	
	)	
Filed: February 12, 2004	)	Confirmation No.: 3478
	)	
For: INSPECTION METHOD, PROCESSOR	)	
AND METHOD FOR MANUFACTURING	)	
A SEMICONDUCTOR DEVICE	)	

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

In reply to the Office Action mailed March 5, 2008, the period for response to which extends through June 5, 2008, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper beginning on page 2.

**Remarks** follow the amendment section of this paper beginning on page 8.